

Form PTO-1449 (Substitute)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		Attorney Docket Number LAZE-01000US0 SRM/MLR		Serial/Patent Number 09/465,592	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)				Applicant/Patent Owner Culver; Rust			
				Filing/Issue Date 12/17/99		Group Art Unit 2653	
U.S. PATENTS							
Examiner Initial		Patent Number	Issue Date	First Named Inventor	Class	Subclass	Filing Date
KE	1.	5,822,285	10/13/98	Rugar et al.	369	44.26	03/31/97
KE	2.	5,835,477	11/10/98	Binnig et al.	369	126	07/10/96
KE	3.	5,856,967	01/05/99	Mamin et al.	369	126	08/27/97
U.S. PATENT PUBLICATIONS							
Examiner Initial		Patent Application Publication Number	Publication Date	Applicant			
				RECEIVED			
				APR 10 2003			
PENDING U.S. PATENT APPLICATIONS							
Examiner Initial		Application Number	Filing Date	First Named Inventor	Technology Center 2600		
					Petition to Expunge? Yes No		
FOREIGN PATENT DOCUMENTS							
Examiner Initial		Document Number	Publication Date	Country	Class	Subclass	Translation Yes No
OTHER DOCUMENTS (Include author (if any), title, publisher and place of publication, date and pertinent pages)							
KE	4.	Barrett, R.C. and Quate, C.F., "Large-scale charge storage by scanning capacitance microscopy," Ultramicroscopy 42-44 (1992) pp. 262-267.					
KE	5.	Gardner, E., "AFM Fabricates a Tiny Transistor," Science, Vol. 266, 28 October 1994, p. 543.					
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KE	7.	Majumdar, A., et al., "Nanometer-scale lithography using the atomic force microscope," Appl. Phys. Lett., Vol. 61, No. 19, 9 November 1992, pp. 2293-2295.					
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9.	Mamin, H.J., et al., "High Density data storage using proximal probe techniques," The IBM Journal of Research and Development, Vol. 39, No. 6, November 1995, pp. 681-699.
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13.	Vettiger, P., et al., "The 'Millipede' — More than one thousand tips for future AFM data storage," The IBM Journal of Research and Development, Vol. 44, No. 3, May 2000, pp. 323-340.
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Examiner

Kim Chun

Date Considered

5/15/03

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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